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### OPTIMIZATION OF THE OPTICAL PARAMETERS IN FABRY-PEROT INTERFEROMETER

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### ABSTRACT

Due to insensitivity to the environmental disturbances, Fabry-Perot interferometers are suitable for displacement measurements under ordinary conditions. In the structure of folded Fabry-Perot interferometer, the results of the signal subdivision are affected by the optical parameters in the resonant cavity. In this paper, the analysis of the Fabry-Perot interferometer for the measurement of the micro-displacement and the long-distance are investigated. By considering the reflectance of the planar mirror and the intensity loss in the resonant cavity, the parameters of systematic optimization which are suitable for the measurement of the micro-displacement and the long-distance and simulated results reveal that the intensity loss in the resonant cavity is 86% and the optimized reflectance of the planar mirror is 12%.

*Keyword* - Fabry-Perot interferometer, Displacement measurement, Resonant cavity.

### 1. INTRODUCTION

Commercial interferometers are with the structure of the non-common optical path, hence the reference beam and the measurement beam are traveling in the different directions. Although the Michelson interferometer has the advantages of simple signal processing, it is sensitive to the environmental disturbances relatively. In view of the above, the Fabry-Perot interferometer of the common optical path is constructed to realize the high resistance to the environmental disturbances.

To simplify the signal processing of the Fabry-Perot interferometer, the optical elements are necessary to be arranged to the resonant cavity and the reflectance of the planar mirror has to be adjusted to change the interferometric signal. However, the complicated resonant cavity and the planar mirror of the different reflectance will lead to more intensity loss and the change of the interferometric finesse. Therefore, according to the previous study which is focused on the folded Fabry-Perot interferometer, a simulation analysis by considering the intensity loss and the reflectance of the planar mirror to achieve the purpose of optimization of the optical parameters in this study.

### 2. THEORETICAL FORMULAS

The optical structure can be applied to the different measurement objective as shown in Fig. 1. Laser beam passes through the BS into the optical cavity. The one-eighth waveplate in the

cavity is utilized to form the orthogonal phase shift between interferometric signals. The polarization axis of the waveplate must be the same as that of PBS. By this arrangement, the orthogonal signal can be acquired by two photodiodes (PDs) and then transmitted to the signal processing module.



Fig. 1 Optical structure of the interferometer

The corresponding equation of the folded Fabry-Perot interferometer can be derived as followings. The amplitude of the firstly reflected beam is expressed as  $A_{S1}$  (2.1) and other interferometric beams can be denoted with  $A_{Sn}$  (2.2), where  $A_0$  is the amplitude of incident light wave, R is the reflectance of the coated glass plate, L is the resultant transmittance of the optical cavity, and n is the order number of the backward reflected light beam.

$$A_{S1} = \frac{-1}{2\sqrt{2}} A_0 \sqrt{R} \tag{2.1}$$

$$A_{\text{Sn}} = \frac{1}{2\sqrt{2}} A_0 T(L)^{n-1} (\sqrt{R})^{2n-3}$$
(2.2)

The corresponding electric field of the interferometric beam can be described as Eq. 2.3 and 2.4, where  $\delta$  is the phase difference of the optical path. In this structure,  $\delta$  is  $\frac{4\pi d}{\lambda}$ , d is the distance between the planar mirror and CCR,  $\omega$  is the angular frequency.

$$E_{Sn} = \frac{1}{2\sqrt{2}} A_0 T(L)^{n-1} (\sqrt{R})^{2n-3} e^{i(\omega t - kx + (2n-2)\cdot\delta)}$$
(2.3)

$$E_{Pn} = \frac{1}{2\sqrt{2}} A_0 T(L)^{n-1} (\sqrt{R})^{2n-3} e^{i(\omega t - kx + (2n-2)\cdot\delta - \frac{\pi}{2})}$$
(2.4)

By Eq. 2.5 and 2.6, the intensity distribution of s-type and p-type can be denoted with Eq. 2.7

and Eq. 2.8.

$$I_{\rm S} = E_{\rm s} \cdot E_{\rm s}^{\ *} \tag{2.5}$$

$$I_{\rm P} = E_{\rm p} \cdot E_{\rm p}^{\ *} \tag{2.6}$$

For s-type (PD1) intensity,

$$I_{S} = E_{s} \cdot E_{s}^{*} = \frac{1}{8} A_{0}^{2} \frac{R(1+L^{2})-2LR\cos(2\delta)}{1+L^{2}R^{2}-2LR\cos(2\delta)}$$
(2.7)

For p-type (PD2) intensity,

$$I_{\rm P} = E_{\rm p} \cdot E_{\rm p}^{*} = \frac{1}{8} A_0^{2} \frac{R(1+L^2) - 2LR\cos\left(2\delta - \frac{\pi}{2}\right)}{1 + L^2 R^2 - 2LR\cos\left(2\delta - \frac{\pi}{2}\right)}$$
(2.8)

### 3. SIMULATION AND ANALYSIS

In accordance with the previous study, the intensity loss in the resonant cavity was influenced by the optical elements and it must to be evaluated. In Fig 2, the intensity loss of the optical elements is measured by the optical power meter at each blue position. In the experiment, the measured intensity loss in the resonant cavity is about 86%.



Fig. 2 Intensity loss in the resonant cavity

The intensity loss in the resonant cavity and the reflectance of 20% and 90% are substituted into the equation 2.7 and 2.8. The corresponding interferometric intensity distributions are demonstrated in Figure 3 and 4.

The simulation results reveal that the reflectance of the planar mirror will affect the energy utilization, the fineness of the interferometric signals, the magnitude and the proximity of the amplitude in the each quadrant. Hence the boundary conditions of the optimized reflectance are necessary to be defined.



To achieve the signal processing function of fine division in the four quadrants, the resolution of each quadrant must be close. Two boundary conditions for defining the reflectance are proposed in this study. The first definition is the amplitude of each quadrant having to be greater than an estimated value. The second definition is the amplitude of each quadrant having to be closer to each other. The Lissajous figure are divided into four quadrants by the maximum signal value of x-axis and y-axis, that is, the peaks of the interferometric signal are as endpoints. Therefore, the period of the interferometric signal can be divided into four equal parts. Because 1st and 3rd quadrant are symmetrical to the straight line with the equation x = y, the amplitude in 1st quadrant and in 3rd quadrant are defined as a and b. The sketch of the light intensity distribution of four quadrants has been illustrated in Fig. 5.



Fig. 5 Division of four quadrants

Each reflectance is substituted into equation 2.7 and 2.8, and then the amplitude from two endpoints to the center of the each Lissajous figure can be obtained. From the simulated results, the amplitude in 1st quadrant is smaller than the other quadrants. Therefore, the maximum value of the amplitude in 1st quadrant is selected for the judgement of the optimized amplitude. Based on the following simulated results, the maximum amplitude in 1st quadrant can be obtained as shown in Table 1. The interferometric intensity distributions are illustrated in Figure 6.

 Ist Quadrant
 Amplitude

 23
 0.021195

 24
 0.021256

 25
 0.021275

 26
 0.021253

 27
 0.021194

 Table 1 Corresponding amplitude in 1st quadrant



However, the uniformity of the amplitude in each quadrant (R: 25%) is not applicable and the reflectance is inversely proportional to the uniformity of the amplitude, the range of the selected reflectance must be redefined between 1% and 25%. The method of the selected reflectance is as the following description, and the definition of the related parameters are demonstrated in Table 2 and Table 4.

To represent the degree of the amplitude decline, the differences between the amplitude of the corresponding reflectance  $(R_n)$  and the corresponding maximum reflectance  $(R_{n'})$  in 1st quadrant are divided by the amplitude of the corresponding maximum reflectance as shown in equation 3.1. And the change rate in amplitude decline can be obtained by the equation 3.2. The simulated results are listed in Table 3.

$$A_{d} = (A_{Rn'} - A_{Rn})/A_{Rn'}$$
(3.1)

$$\mathbf{r}_{\mathbf{d}} = \mathbf{A}_{\mathbf{d}+1} - \mathbf{A}_{\mathbf{d}} \tag{3.2}$$

Symbol Table			
R <sub>n</sub>	$R_n$ Reflectance (n: 1 ~ 24%)		
R <sub>n</sub> ,	$R_{n'}$ Reflectance (n': 25%)		
A <sub>Rn</sub>	$A_{Rn}$ Amplitude (R: 1 ~ 24 %)		
A <sub>Rn</sub> ,	Maximum amplitude (R: 25 %)		
A <sub>d</sub>	A <sub>d</sub> Amplitude decline		
r <sub>d</sub>	The rate of change in amplitude decline		

#### Table 2 Related parameters of the amplitude decline

Table 3	Simulated	results	of the	amplitude	decline

	R <sub>n</sub>	A <sub>Rn</sub>	A <sub>d</sub> (%)	r <sub>d</sub> (%)
	1	0.002076	90.2	9.0
	2	0.004011	81.2	8.5
	3	0.005809	72.7	7.8
((	))	))	)) ((	"
	22	0.021088	0.9	0.5
	23	0.021195	0.4	0.3
	24	0.021256	0.1	0.1
	R <sub>n</sub> ,	A <sub>Rn</sub> ,		
	25	0.021275		

To represent the degree of the amplitude proximity, the differences between the maximum amplitude and the minimum amplitude of each corresponding reflectance are divided by the difference between the maximum amplitude and the minimum amplitude of the corresponding maximum reflectance as demonstrated in equation 3.3. The change rate in amplitude proximity can be obtained by the equation 3.4. The simulated results are listed in Table 5.

$$A_{p} = |b_{Rn} - a_{Rn}| / |b_{Rn'} - a_{Rn'}|$$
(3.3)

$$\mathbf{r}_{\mathbf{p}} = \mathbf{A}_{\mathbf{p}+1} - \mathbf{A}_{\mathbf{p}} \tag{3.4}$$

### Table 4 Related parameters of the amplitude proximity

Symbol Table			
R <sub>n</sub>	$R_n$ Reflectance (n: 1 ~ 24%)		
R <sub>n</sub> ,	Reflectance (n: 25%)		
a	Amplitude of 1 <sup>st</sup> quadrant		
b	Amplitude of 3 <sup>rd</sup> quadrant		
Ap	Amplitude proximity		
r <sub>p</sub>	The rate of change in amplitude proximity		

		1 1	2
R <sub>n</sub> (%)	$b_{Rn} - a_{Rn}$	A <sub>p</sub> (%)	r <sub>p</sub> (%)
1	0.000072	0.2	0.8
2	0.000285	1	1.0
3	0.000631	2	1.6
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22	0.024277	81.8	6.0
23	0.026059	87.8	6.1
24	0.027865	93.9	6.2
R <sub>n</sub> ,	$b_{Rn'} - a_{Rn'}$		
25	0.029691		

## Table 5 Simulated results of the amplitude proximity

From the results of  $r_d$  and  $r_p$ , the two change rates are inversely proportional to each other with the change of the reflectance. In order to determine the cross/optimal point between two change rates, the curves of these two rates are demonstrated in Fig. 7. The obtained intersection point (R: 12%) is the optimal value of the reflectance as shown in Fig. 8.





#### 4. CONCLUSION

The fineness of the interferometric signal is influenced by the intensity loss of the resonant cavity and the reflectance of the planar mirror. By considering the reflectance of the planar mirror and the intensity loss of the resonant cavity to construct the theoretical simulation in this paper is realized. The experimental results reveal that the intensity loss in the resonant cavity is 86%. And by the simulated results, the optimized reflectance of the planar mirror is 12%.

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